



SMC-00-143

November 29, 2000

To: Commissioner of Patents and Trademarks
Washington, D.C. 20231

Fr: George O. Saile, Reg. No. 19,572
20 McIntosh Drive
Poughkeepsie, N.Y. 12603

Subject:

Serial No. 09/669,159 09/25/00

Horn-Wen Chen, Chi-How Wu

AN IN-SITU STRIP PROCESS FOR
POLYSILICON ETCHING IN DEEP
SUB-MICRON TECHNOLOGY

Grp. Art Unit: 1763

ASSOCIATE POWER OF ATTORNEY

I hereby appoint Rosemary L.S. Pike, registration number 39,332, as my associate attorney in this case. Her telephone number is (765) 453-0866.

Please continue to direct all correspondence in this case to the undersigned attorney.

Respectfully submitted,

Stephen B. Ackerman,

Principal attorney of record

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TC 1700 MAIL ROOM